



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 29, 2026	
IGI Report Number	LG804622866
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.71 - 8.76 X 5.24 MM

GRADING RESULTS

Carat Weight	2.43 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	IDEAL

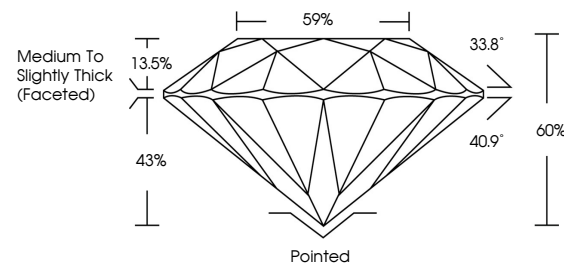
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG804622866

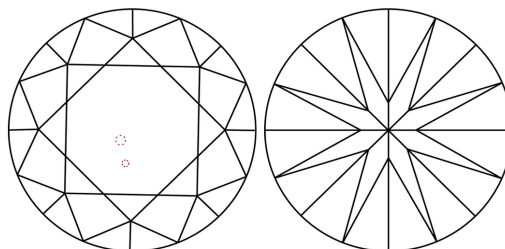
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG804622866
Report verification at igi.org

PROPORTIONS

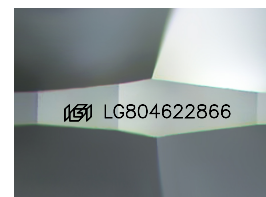


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

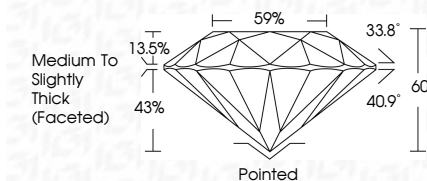
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

	VIS 1	2.43 CARATS
	IDPL	E
	60%	
	59%	
	Medium to Slightly Thick (Faceted)	
Culet	Poished	
Polish	EXCELLENT	
Symmetry	EXCELLENT	
Fluorescence	NONE	
Inscriptions(s)	(g) L580462266	
Comments:		
		Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
		Type IIG